Notice of Allowability	Application No.	Applicant(s)	
	10/618,988	KO, CHANG JIN	
	Examiner	Art Unit	
	Renee R Berry	2818	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet we (OR REMAINS) CLOSED i) or other appropriate comm (IGHTS. This application is	ith the correspondence address n this application. If not included unication will be mailed in due course.	
1. This communication is responsive to <u>07/02/04</u> .			
2. The allowed claim(s) is/are <u>3-6</u> .			
3. \boxtimes The drawings filed on <u>14 July 2004</u> are accepted by the Ex	xaminer.		
 4. Acknowledgment is made of a claim for foreign priority u a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN 	e been received. e been received in Application cuments have been received of this communication to file	on No d in this national stage application fron	
 THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subminformal patent APPLICATION (PTO-152) which give 	nitted. Note the attached EX	AMINER'S AMENDMENT or NOTICE r declaration is deficient.	OF
6. ☐ CORRECTED DRAWINGS (as "replacement sheets") mu (a) ☐ including changes required by the Notice of Draftsper		w (PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date	's Amendment / Comment o	r in the Office action of	
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on t the header according to 37 C	he drawings in the front (not the back) o FR 1.121(d).	of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	DISIT OF BIOLOGICAL MAT FOR THE DEPOSIT OF BI	ERIAL must be submitted. Note the OLOGICAL MATERIAL.	;
Attachment(s) 1. Notice of References Cited (PTO-892)	5. ☐ Notice of I	nformal Patent Application (PTO-152)	
2. \square Notice of Draftperson's Patent Drawing Review (PTO-948)		Summary (PTO-413),	
Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date	08), 7. 🗌 Examiner's	/Mail Date s Amendment/Comment	
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	8. ☐ Examiner's 9. ☐ Other	Statement of Reasons for Allowance	
. Storogical Material		_	
David Nelms			
Supervisory Palent Examiner Technology Genter 2800			

Application/Control Number: 10/618,988

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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: There is no prior art of record that teaches or suggests a method for burying or filling pores on sidewalls of the via hole when the via hole extends through a porous film to an underlying base and forming a CVD TiN Film with a thickness of 10 to 20 Angstroms to bury or fill only the pores on the sidewalls of the via hole.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Renee R Berry whose telephone number is (571) 272-1774. The examiner can normally be reached on M-F 9-5:30.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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RRB

October 1, 2004

David Nelms
Supervisory Patent Examiner
Technology Center 2800